

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yoo, Woo Sik

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Assignee: WaferMasters, Inc.

SEP 01 2004

Title: Gas-Assisted Rapid Thermal Processing

Serial No.: 10/005,827 Filing Date: November 8, 2001

Examiner: Trinh, M. Group Art Unit: 2822

Docket No.: M-11914 US

Irvine, California  
September 1, 2004

MAIL STOP AF  
COMMISSIONER FOR PATENTS  
P.O. Box 1450  
Arlington, VA 22313-1450

RESPONSE TO FINAL OFFICE ACTION

Dear Sir:

In response to the Final Office Action dated May 5, 2004, Applicant submits the following amendments and remarks. A one-month extension of time, extending the period for response to September 5, 2004, is requested in an accompanying petition.

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